



AP 2818/\$
PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date February 17, 2004

In re the Application of

Kiyoichi SUWA

Group Art Unit: 2818

Application No.: 09/729,339

Examiner: Q. Hoang

Filed: December 5, 2000

Docket No.: 108057

For: MASK, EXPOSURE METHOD, LINE WIDTH MEASURING METHOD, AND METHOD FOR
MANUFACTURING SEMICONDUCTOR DEVICES

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

RECEIVED

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

FEB 23 2004

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired November 27, 2003, an extension of time for a period of three months is hereby requested. Attached hereto is our Check No. 151074 in the amount of \$950.00 in payment for:

| | |
|--------------|---|
| _____ | Extension fee for response within first month pursuant to §1.136(a) (\$110.00) |
| _____ | Extension fee for response within second month pursuant to §1.136(a) (\$420.00) |
| <u> X </u> | Extension fee for response within third month pursuant to §1.136(a) (\$950.00) |

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

Mario A. Costantino
Registration No. 33,565

MAC/ccs

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**DEPOSIT ACCOUNT USE
AUTHORIZATION**
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461